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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Hadizad et al.  
Serial No.: 09/802,726  
Filing Date: March 12, 2001  
Group Art Unit: 2813  
Examiner: Schillinger, Laura M  
Title: SEMICONDUCTOR COMPONENT AND METHOD OF MAKING

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Lydia McNamara SEMICONDUCTOR COMPONENTS INDUSTRIES,  
LLC

Name of Person Signing Certificate Lydia McNamara Name of Assignee

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SUBMITTAL OF FORMAL DRAWINGS

Honorable Commissioner of Patents and Trademarks,  
P.O. Box 1450  
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Attn: Official Draftsperson

SIR:

Enclosed are seven (7) sheets of formal drawings for the above-identified  
patent application in response to the Office Action mailed November 7,  
2003.

Respectfully submitted,

Peyman Hadizad et al.



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